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TO: Ori Nadav

FAX NO.: (571) 273-8300

TEL NO.: (571) 272-1660

FROM: Mary Adams-Moe

DATE: January 23, 2009

NO. OF PAGES: 4
(including cover page)

RE: Application No. 10/840,125 filed 05/06/2004

MESSAGE

PTOL 415A (07-07)
Approved for use through 09/30/2007. OMB 0651-0031
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Applicant Initiated Interview Request Form					
Application No.: <u>10/840,125</u>		First Named Applicant: <u>Steve Ming Ting</u>		Status of Application: <u>Final OA</u>	
Examiner: <u>Nolan, DC</u>		Art Unit: <u>2811</u>			
Tentative Participants:					
(1) <u>Mary Adams-Moe</u>		(2) _____			
(3) _____		(4) _____			
Proposed Date of Interview: <u>Any Time (Tues 1-27)</u>			Proposed Time: <u>10:30</u> (AM/PM) <u>Eastern Time</u>		
Type of Interview Requested:					
<input checked="" type="checkbox"/> (1) Telephonic		<input type="checkbox"/> (2) Personal		<input type="checkbox"/> (3) Video Conference	
Exhibit To Be Shown or Demonstrated: <input type="checkbox"/> YES <input checked="" type="checkbox"/> NO					
If yes, provide brief description: _____					
Issues To Be Discussed					
Issues (Rej., Obj., etc)	Claims/ Fig. #s	Prior Art	Discussed	Agreed	Not Agreed
(1) <u>Obj To Figure 1J</u>			<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
(2) <u>Reg 112 - Claim 16</u>			<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
(3) _____			<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
(4) _____			<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
<input type="checkbox"/> Continuation Sheet Attached					
Brief Description of Arguments to be Presented:					
<u>Proposal sent in Attached Agenda</u>					
An interview was conducted on the above-identified application on _____.					
NOTE: This form should be completed by applicant and submitted to the examiner in advance of the interview (see MPEP § 713.01).					
This application will not be delayed from issue because of applicant's failure to submit a written record of this interview. Therefore, applicant is advised to file a statement of the substance of this interview (37 CFR 1.133(b)) as soon as possible.					
_____ Applicant/Applicant's Representative Signature			_____ Examiner/SPE Signature		
Typed/Printed Name of Applicant or Representative					
<u>Mary Adams-Moe</u>					
Registration Number, if applicable					
<u>57883</u>					

This collection of information is required by 37 CFR 1.130. The information is required to obtain or retain a benefit by the public which is in the (not by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 422 and 37 CFR 1.111 and 1.14. This collection is estimated to take 21 minutes to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22312-1450. DO NOT SEND FEE OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22312-1450.

If you need assistance in completing the form, call 1-800-PTO-9199 and select option 2.

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

RECEIVED
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JAN 23 2009In re application:
Notched Spacer for CMOS transistors.§
§

Application No.: 10/840,125

§
§

Group Art Unit: 2811

Filed: 05/06/2004

§
§

Examiner: Nadav, Ori

Inventor:
Steve Ming Ting§
§Attorney Docket No.:
TSM03-0945§
§AGENDA FOR TELEPHONE INTERVIEW

Dear Examiner Nadav,

I would like to schedule a phone interview with you concerning application number 10/840,125. The application has been through appeal and is now once again at a final OA. Perhaps if we spoke and cleared up a few issues we could make forward progress on this application.

1. Objection to drawing 1J. While the Applicant feels that the figure as it stands is supported, perhaps there is a modification to the drawing that could render it acceptable to you, thus furthering prosecution.

2. The 112 second paragraph rejection of claims 16-23. Again while the Applicant feels that the claims as it stands is supported,
"forming a notched spacer alongside the gate electrode such that a thickness of the notched spacer alongside the gate electrode is thinner near the substrate..."

The OA indicated that the phrase,
"a notched spacer is thinner at a first portion closer to the surface of the substrate than at a second portion being further from the substrate" Applicant feels these phrases are close in meaning and would like to understand the ramifications of making such a language change.

Times between 10:30 – 4:00 Eastern Time is the best time for me, however I will adjust my schedule to anytime that is convenient for you. Thank-you, in advance for your consideration.

Best Regards,
Mary

Mary Adams-Moe
Reg. No. 57,883
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